



Attorney Docket No. 0756-7293

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Patent Application of:

Koichiro TANAKA et al.

Serial No. 10/827,449

Filed: April 20, 2004

For: BEAM HOMOGENIZER, LASER

IRRADIATION APPARATUS, AND

METHOD FOR MANUFACTURING

SEMICONDUCTOR DEVICE

) Group Art Unit: 2874

) Examiner: M. Stahl

) CERTIFICATE OF MAILING

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) 2007.

Adrian M. Stamps

RESPONSE

Honorable Commissioner of Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

The Official Action mailed May 15, 2007, has been received and its contents carefully noted. This response is filed within three months of the mailing date of the Official Action and therefore is believed to be timely without extension of time. Accordingly, the Applicant respectfully submits that this response is being timely filed.

The Applicant notes with appreciation the consideration of the Information Disclosure Statements filed on April 20, 2004; July 21, 2005; November 13, 2006; January 17, 2007; February 27, 2007; and March 13, 2007.

A further Information Disclosure Statement is submitted herewith and consideration of this Information Disclosure Statement is respectfully requested.

Claims 1-50 are pending in the present application, of which claims 1, 5, 9, 13, 17, 23, 29, 37 and 43 are independent. The Applicant notes with appreciation the allowance of claims 5-16 and 23-48 (pages 5-6, Paper No. 20070501). For the reasons set forth in detail below, all claims are believed to be in condition for allowance. Favorable reconsideration is requested.